

Electronic Patent Application Fee Transmittal

Application Number:	10660813			
Filing Date:	12-Sep-2003			
Title of Invention:	REACTIVE ION ETCHING FOR SEMICONDUCTOR DEVICE FEATURE TOPOGRAPHY MODIFICATION			
First Named Inventor/Applicant Name:	Hemant P. Mungekar			
Filer:	Steven Charles Crocker/Yolande Glass			
Attorney Docket Number:	A7600P1/T51700			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
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Total in USD (\$)				1810